March 2015

Architecting SkyBridge-CMOS

Mingyu Li
University of Massachusetts Amherst

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ARCHITECTING SKYBRIDGE-CMOS

A Thesis Presented

by

MINGYU LI

Submitted to the Graduate School of the
University of Massachusetts Amherst in partial fulfillment
of the requirements for the degree of

MASTER OF SCIENCE IN ELECTRICAL AND COMPUTER ENGINEERING

February 2015

Electrical and Computer Engineering
ARCHITECTING SKYBRIDGE-CMOS

A Thesis Presented

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ACKNOWLEDGEMENTS

With this opportunity I express my gratitude to my advisor Professor Csaba Andras Moritz. You have been constantly encouraging and guiding me throughout my Master study. I would like to thank you for mentoring me to grow as a learner, researcher and a Ph.D. candidate. Your advice on my research will forever be my guidelines in my future work and career. I would also like to express my appreciation to my dissertation committee members Professor Krishna and Professor Koren for their priceless advices on my thesis work. Your feedback has inspired me to achieve more during my research.

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ABSTRACT

ARCHITECTING SKYBRIDGE-CMOS

FEBRUARY 2015

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As the scaling of CMOS approaches fundamental limits, revolutionary technology beyond the end of CMOS roadmap is essential to continue the progress and miniaturization of integrated circuits. Recent research efforts in 3-D circuit integration explore pathways of continuing the scaling by co-designing for device, circuit, connectivity, heat and manufacturing challenges in a 3-D fabric-centric manner. SkyBridge fabric is one such approach that addresses fine-grained integration in 3-D, achieves orders of magnitude benefits over projected scaled 2-D CMOS, and provides a pathway for continuing scaling beyond 2-D CMOS.

However, SkyBridge fabric utilizes only single type transistors in order to reduce manufacture complexity, which limits its circuit implementation to dynamic logic. This design choice introduces multiple challenges for SkyBridge such as high switching power consumption,
susceptibility to noise, and increased complexity for clocking. In this thesis we propose a new 3-D fabric, similar in mindset to SkyBridge, but with static logic circuit implementation in order to mitigate the afore-mentioned challenges. We present an integrated framework to realize static circuits with vertical nanowires, and co-design it across all layers spanning fundamental fabric structures to large circuits. The new fabric, named as SkyBridge-CMOS, introduces new technology, structures and circuit designs to meet the additional requirements for implementing static circuits. One of the critical challenges addressed here is integrating both n-type and p-type nanowires. Molecular bonding process allows precise control between different doping regions, and novel fabric components are proposed to achieve 3-D routing between various doping regions.

Core fabric components are designed, optimized and modeled with their physical level information taken into account. Based on these basic structures we design and evaluate various logic gates, arithmetic circuits and SRAM in terms of power, area footprint and delay. A comprehensive evaluation methodology spanning material/device level to circuit level is followed. Benchmarking against 16nm 2-D CMOS shows significant improvement of up to 50X in area footprint and 9.3X in total power efficiency for low power applications, and 3X in throughput for high performance applications. Also, better noise resilience and better power efficiency can be guaranteed when compared with original SkyBridge fabrics.
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CHAPTER 1
INTRODUCTION

CMOS-based integrated circuits have been constantly developing thanks to the continuous scaling of MOSFETs. As lithography and process techniques improve, feature size shrinks, driving transistors to become smaller and cheaper, switch faster, and consume less power. The advancements in devices have been leading the progress and miniaturization of integrated circuits.

However, when channel length of MOSFETs approaches nanoscale domain, many challenges appear in various aspects of fabrication and device, which prevents the further scaling of CMOS transistors. Moreover, solely focusing on the improvement of device has been less effective in nanoscale regime since interconnection costs are dominating [1]. All these challenges will be introduced in details in the following paragraphs.

First of all, CMOS fabrication and manufacturing have been more difficult than ever before due to the extremely high requirements in building MOSFETs in nanoscale. In terms of lithography precision, it has been extremely challenging to define the small feature size in tens of nanometers as we can see in Figure 1.1 [2]. In order to reduce variations and ensure reliability, very precise lithography technique needs to be developed. As for doping control, conventional MOSFETs in nanoscale with ultra-sharp abrupt doping junctions necessitating orders of magnitude in doping concentration variation across several nanometers [3], which is difficult for doping control and may thus lead to great variations.
Second, non-ideal characteristics become more severe as CMOS device scales. On one hand, subthreshold leakage current issue turns to be more difficult to be controlled in short channel transistors. The decreased on-off current ratio leads to more significant static power dissipation. This scaling trend in static power is in contrary to the one of active power consumption, making static power consumption more critical particularly in on-chip memories [4]. On the other hand, the threshold voltage scaling has also slowed down dramatically to prevent subthreshold leakage power from going up too fast in nanoscale regime, which makes the dynamic power efficiency still high. Thus it is no more possible to obtain both performance and power benefit at the same time [5]. The more usual way of dealing the trade-off is to limit the performance from scaling up too fast as is shown in the Figure 1.2 [2].
Moreover, as the integration scale and gate density increase, interconnection cost is gradually dominating power consumption and performance in recent technology nodes. Contrary to the device-scaling trend, interconnection per unit length leads to larger parasitic resistance and capacitance and consumes more power. What is more, die size has been gradually increasing, making global wiring overhead larger than before.

Confronted with afore-mentioned challenges, it has been more difficult and less beneficial to remain the progress of CMOS-based integrated circuit by continuing scaling the current MOSFET design. Consequently revolutionary technology beyond the end of CMOS roadmap is essential for the development of charge-based electronics.
CHAPTER 2

OVERVIEW OF SKYBRIDGE FABRIC

In this chapter, a recently proposed innovative 3-D integration technology named as SkyBridge [6] will be briefly introduced as a solution for the further CMOS technology scaling. Afterwards, we will introduce challenges in SkyBridge, which motivates us to further explore possible extensions based on this new fabric.

2.1 Motivation and Overview of SkyBridge

In the last chapter, it has been introduced that the further CMOS technology scaling has encountered several challenges in fabrication, device and connectivity. These problems are not easily solvable if we continue the conventional scaling by simple shrinking channel length and engineering the design parameters and structure. It is thus necessary to achieve a revolutionary technology by co-designing in all the aspects including material, device, circuit, interconnection, heat management and fabrication.

Following this mindset, a new fabric named as SkyBridge has recently been proposed. In this technology, the 3-D fabric-centric manner is followed to address fine-grained 3-D integration and mitigate the afore-mentioned CMOS scaling problems [6]. At the same time, with the true 3-D integration, SkyBridge achieves orders of magnitude benefit in density and power over projected scaled 2-D CMOS technology.
The 3-D fabric-centric manner in SkyBridge is followed by bringing in innovative features other than the planar MOSFETs and interconnection structures in CMOS. First,
as shown in the Figure 2.1, SkyBridge circuits are built and stacked on vertical nanowires, which makes the definition of channel length dependent on material deposition instead of lithography limitation. Second, SkyBridge fabric performs logics with Gate-All-Around junctionless transistors to better suppress the leakage current and reduce doping complexity. Third, noise mitigation mechanism in SkyBridge allows the faster static circuit implementation. At last, interconnections are redesigned in SkyBridge. The better connection structures, together with the higher gate density, provide better connectivity beyond the bottleneck in traditional 2-D CMOS technology. All these features, together with the routing and heat management strategies, are shown in the Figure 2.2 and realize the true 3-D integration in a “fabric-centric” manner.

2.2 Challenges in SkyBridge Fabric

In order to reduce the fabrication complexity, one uniform n-type doping is applied to the wafer, limiting the transistors to only n-type [6]. This design choice leads the implementation to only dynamic circuit style and incurs challenges.

First of all, dynamic SkyBridge circuits are more susceptible to noise. The control scheme, as shown in Figure 2.3, enables fast gate transitions but leaves the output signals floating during the “HOLD” phase as well. The floating output is only held by capacitance attached to the gate output and thus vulnerable to coupling capacitances.
Second, according to the control scheme, SkyBridge is not efficient in some scenarios. For example, in the scenario shown in the Figure 2.4 when consecutive “zero” results are expected, the gate output keeps being precharged and discharged during the “Precharge” and “Evaluate” phases. These switches are redundant and consume unnecessary power.

Figure 2.4. Switch in static and dynamic circuits when output=0
At last, clocking routing for dynamic circuits brings large overhead. SkyBridge circuits require three or four kinds of clock signals depending on whether single-rail or dual-rail implementation is used. Moreover, these various kinds of clock signals need to be routed to every gate in dynamic SkyBridge circuits. While in static circuits, they are only routed to the sequential elements such as flip-flops and register files. The more complex clocking leads to overhead in performance, power and area footprint.

Confronted with all these challenges caused by static circuit implementation in SkyBridge fabric, we are motivated to explore the possibility and benefit of SkyBridge extension to static circuit. This thinking has led us to the new SkyBridge-CMOS fabric that is going to be introduced in the following chapters.
CHAPTER 3

OVERVIEW OF SKYBRIDGE-CMOS

This chapter introduces the motivation of applying 3-D integration technology with static CMOS-style circuit implementations. An overview concept of the new SkyBridge-CMOS fabric is then provided. At last, detailed introductions about the core components in SkyBridge-CMOS fabric are presented.

3.1 Motivation

In the previous chapter, several challenges in SkyBridge fabric are introduced: outputs are floating during their “Hold” phases and thus susceptible to noise; redundant switches happen between consecutive “zero” outputs due to the dynamic control scheme; complex clock routing leads to overhead in area, power and performance. All these limitations are related with the dynamic circuit style in SkyBridge fabric and can possibly be mitigated with static circuit implementations. Consequently we are motivated to explore implementing static circuits in the similar 3-D integration.

3.2 Overview of SkyBridge-CMOS

Confronted with the challenges from dynamic implementations, a new fabric, similar in mindset to SkyBridge, but with static logic circuit implementation is proposed. The new integrated framework is co-designed across all layers spanning fundamental fabric structures to large circuits to realize efficient static circuit implementations with vertical nanowires. The new fabric, named as SkyBridge-CMOS, introduces new technology, structures and circuit designs to meet the additional requirements for implementing static circuits. One of the critical challenges addressed here is integrating both n-type and p-
type nanowires. Molecular bonding process [7] allows precise control between different doping regions, and novel fabric components are proposed to achieve complementary function device and 3-D routing between various doping regions.

3.3 Core Components

In this section, core components in SkyBridge-CMOS fabric will be introduced. On one hand, some elements are inherited from the original SkyBridge fabric to realize the similar mindset of 3-D integration based on vertical nanowires; on the other hand, some of these SkyBridge elements are re-engineered and new components are designed to meet the doping and routing requirement of implementing static circuit style. All these core components will be introduced in the following content of the chapter.

3.3.1 Vertical Nanowires

Vertical single crystalline silicon nanowire array acts as the fundamental building blocks of SkyBridge-CMOS fabric [6]. All the elements including active devices, contacts and interconnections are based on nanowires. The nanowires are classified into two kinds: one is named as logic nanowires where transistors are built to implement logics; the other is named as routing nanowires where silicon layer is used for signal propagation. These nanowires need to be heavily doped to meet the doping concentration requirement of junctionless transistor channels [3]. What is more, silicidation on the surface of silicon nanowires is necessary to improve the conductivity.

In SkyBridge-CMOS fabric, since two types of transistors are needed, precisely controlled regions with various doping on nanowire arrays are essential. However, good lateral doping control is hard to achieve when a high doping aspect ratio is also desired.
Thus the solution of doing n- and p-type doping in different regions for the two transistor types may be challenging. We then turn to another way which achieves one to-be-patterned substrate with various doping layers by bonding several substrates with different doping profiles together. A technology named as molecular bonding has been proposed and proved to be successful [7]. With molecular bonding, a wafer with several active layers and dielectric layers in between is obtained. When preparing for a SkyBridge-CMOS substrate, an n-doped wafer and a p-doped wafer is bonded together to obtain a substrate with various doping regions as well as a dielectric layer in between, as shown in the Figure 3.1. The dielectric layer, named as SkyBridge-Interlayer-Dielectric, provides isolation between p- and n-doped regions when the connection is not desired. We would not like to make this layer too thick because of the nanowire aspect ratio limitation. Regarding this problem, a SkyBridge-Interlayer-Dielectric layer as thin as 23nm has been proposed [8]. What is more, by doing the process iteratively, more layers with different doping can be stacked.

![Figure 3.1. Substrate with Layered Doping Regions](image-url)
After the silicon substrate with doping layers is prepared, highly anisotropic silicon etching is desired in order to achieve nanowires with high aspect ratio and uniform width. In this way, finally we achieve nanowires with different doping regions and SkyBridge-Interlayer-Dielectric in between as shown in the Figure 3.2. This top-down method ensures the quality of silicon, surface profiles and good geometry parameter control of nanowires [9].

Figure 3.2. Nanowires with p-, n- doped regions and SB-ILD

3.3.2 Transistors

The active devices used in SkyBridge-CMOS fabric are vertical Gate-All-Around junctionless nanowire transistors. Junctionless transistors avoid the abrupt junctions in conventional MOSFETs and thus reduce the doping complexities. Moreover, due to the vertical structure, channel lengths of SkyBridge-CMOS transistors are defined by the
thickness of material deposition instead of lithography accuracy, which allows the continuous channel length scaling beyond the lithography limitation.

The electrical behavior is modulated by the Workfunction difference between gate material and channel. So proper gate electrode Workfunction is important. The transistor channels should be in depletion by the Workfunction difference if no gate voltage is applied and in conduction with right gate voltage applied. Thus the gate material is chosen based on the Workfunction range, which is shown in the Figure 3.3, and on the electric characteristics. The previous design, which is shown in Figure 3.4, for n-type transistor uses Titanium Nitride as gate material and Boron-doped silicon with a high concentration of 1e19 cm$^{-3}$, resulting in an on current of 1.63e-5A and an on-off ratio of 1.72e5. For p-type transistors, we have chosen Tungsten Nitride as gate electrode material and has a design shown in Figure 3.5. In order to have a similar on current with n-type transistors and decent on-off ratio, further refinement on the gate electrode Workfunction and channel doping concentration has been applied with Sentaurus TCAD simulation [10], leading us to the results of 4.54 for Workfunction, achieved by WN$_{0.6}$ [11], and 0.8e5 cm$^{-3}$ for Arsenic doping concentration. With all these optimizations, we make the on-current 1.6e-5A and on-off ratio 2.1e4 for p-type transistor, which shows the similar driving ability with n-type transistors and good on-off ratio.
Figure 3.3. Gate Material Choice

Figure 3.4. N-type Transistor in SkyBridge-CMOS
3.3.3 Contacts

Contact materials also need to be chosen based on the Workfunction difference for good Ohmic contact. Consequently different kinds of contact material are required for diverse doping regions. In SkyBridge, silicon is always n-doped so only one type of contact needs to be designed. Titanium provides good Ohmic contact with n-doped silicon and good conductivity and thus it is chosen as the contact electrode material. As for the p-type contact in SkyBridge-CMOS fabric, Workfunction of contact material needs to be similar or slightly higher than the p-doped silicon. Among the commonly used materials, nickel is chosen based on the Workfunction requirement. Contact designs based on these material choices are shown in the Figure 3.6. The fact that we are using two different kinds of contact material is not adding fabrication complexity since the n-
type and p-type contacts are always on different layers. A silicided layer between contact material and silicon is also necessary to decrease the contact resistance.

![Diagram of N- and P-type Contact](image)

**Figure 3.6.** N- and P-type Contact

### 3.3.4 Bridges and Coaxial Routing

Two kinds of routing structures have been used in SkyBridge-CMOS fabric: Bridges in SkyBridge-CMOS fabric provides connection between adjacent nanowires; coaxial routing structure offers connectivity in vertical direction to allow more interconnection flexibility.

In order to improve the connectivity, bridges can be built at different nanowire heights so that multiple bridges are available on one nanowire. Additionally at most two metal layers and one silicon layer for coaxial routing are allowed to increase the vertical
connectivity. Figure 3.7 shows an example of integrating multiple bridges and coaxial routing layers to achieve high connectivity.

Both two kinds of metal routing structures are built with tungsten, which is the material widely used as interconnection in conventional 2-D CMOS technology. The material choice is not only based on its good electric characteristics as interconnection, but on the compatibility with other materials as well. The connection between tungsten and n-type contact / gate material has been proved feasible in original SkyBridge fabric. To allow tungsten connected with nickel, a titanium nitride barrier layer is essential to prevent the inter-diffusion [12].

![Diagram of interconnections](image)

**Figure 3.7.** Interconnections: Coaxial Routing and Bridge

### 3.3.5 SkyBridge-Interlayer-Connections

One important challenge for realizing static circuits on vertical nanowires in 3-D integration is to effectively perform the connection between n- and p-doped silicon regions. The connection is necessary in two conditions: one is for connecting pull-up and
pull-down networks to implement static logic gates; the other is to allow vertical signal routing to bypass the SkyBridge-Interlayer-Dielectric.

The structure of SkyBridge-Interlayer-Connection are shown in the Figure 3.8. It includes connections through p-doped silicon, nickel, titanium nitride, tungsten, titanium and n-doped silicon. These materials are chosen so that good Ohmic contact and material bonding are achieved for every connection existing in the SkyBridge-Interlayer-Connection. Due to its complicated structure, electrical characteristic should be verified to ensure good connectivity between two terminals. We used Sentaurus TCAD tools to simulate the process for building the SkyBridge-Interlayer-Connection structures and the device characteristics in physical level. The electrical characteristics of SkyBridge-Interlayer-Connection are going to be plotted during the evaluation. A linear I-V characteristics will show that SkyBridge-Interlayer-Connections are providing good Ohmic contact between two terminals in various doping regions.

![SkyBridge-Interlayer-Connection](image)

**Figure 3.8.** SkyBridge-Interlayer-Connection
CHAPTER 4
SKYBRIDGE-CMOS CIRCUIT IMPLEMENTATIONS

This chapter provides an overview of SkyBridge-CMOS circuit style. Also, some circuit design examples including logic gates, arithmetic circuits and Static RAM are shown in transistor-level schematics and 3-D physical-level layouts.

4.1 Overview of SkyBridge-CMOS Circuit Style

Limitations from the dynamic circuit style in SkyBridge fabric motivate us to explore the possibility of implementing static circuits in 3-D integration. Consequently, afore-introduced new core components are designed for SkyBridge-CMOS: p-type transistors can build pull-up network without generating degraded “1”; SkyBridge-Interlayer-Dielectric provides reliable isolation between p- and n-doped nanowire regions; SkyBridge-Interlayer-Connections connects p- and n-doped silicon when connection is desired. All these elements make it possible to achieve static circuits in 3-D integration similar with SkyBridge fabric.

In SkyBridge-CMOS fabric, the conventional circuit style to implement static circuits in planar CMOS technologies is followed. In this style, each gate consists of a pull-down network to ground with n-type transistors and a pull-up network to VDD with p-type transistors VDD as shown in the Figure 4.1 [13]. Important improvements in terms of power consumption and noise resilience can be achieved with static circuit style: either pull-up or pull-down network is ON due to the nature of static circuits, making the gate output always driven by strong “1” or “0” and thus ensuring good noise robustness; static logic is more energy-efficient due to the absence of redundant switches from precharge-
evaluation mechanism used in dynamic circuits; static CMOS-style circuits greatly reduce clocking overhead since clock signals no longer need to be routed to every gate as in dynamic circuits.

![SkyBridge-CMOS Circuit Style](image)

**Figure 4.1.** SkyBridge-CMOS Circuit Style

Another feature in SkyBridge-CMOS fabric is compound logic. Similarly with conventional CMOS circuits, a combination of series and parallel transistors can implement more functions besides “NAND” and “NOR”. As we will see in Section 4.2.3, a compound gate is able to perform the “AOI2” logic in a single stage with a compact and efficient gate design.

As we can see, SkyBridge-CMOS fabric shares similar transistor-level circuit design methods in terms of static circuit style and compound logic. The similarity provides better compatibility with the state-of-art CAD tools and thus makes it easier for large scale circuit design than the original SkyBridge.
4.2 Elementary Logic Gates

Following the previously introduced circuit styles, we are now able to design elementary logic gates in SkyBridge-CMOS fabric, which are going to be described in the following paragraphs.

4.2.1 Inverters

First of all, the SkyBridge-CMOS circuit implementation of inverter, which applies the simplest logic, is presented. Also, by showing the physical-level layout of several cascaded inverters, routing strategy between gates is shown.

The layout of a single inverter is included in Figure 4.2. The Ohmic contacts to n- and p-doped silicon connect output node to power supply through pull-up network and to GND through pull-down network. Input signal is routed to gate electrodes surrounding the nanowire channels and control the on-off state of corresponding transistors. In between the two doping regions, SkyBridge-Interlayer-Connection structure connects the pull-up and pull-down network together to generate the output logic. From the figure we can see that all the contacts and gates are stacked vertically and thus a very small area footprint is occupied.
The layout of four cascaded inverters is then shown in the Figure 4.3. Through this design we are focusing on how the routing between these cascaded inverters are made. Firstly primary input signal “In” is connected to both pull-up and pull-down network by the coaxial routing structure on a nanowire dedicated for signal routing. However, this routing strategy leads to large overhead since the routing nanowire is no longer available for implementing logic. One way to avoid using routing nanowire is to customize the nanowire heights of outputs and inputs so that they can be connected directly by bridges. The signals “Int0”, “Int1” and “Int2” as shown in Figure 4.3 are following this routing strategy.

Figure 4.2. Physical Layout of SkyBridge-CMOS Inverter
4.2.2 NAND Gate

In this section, a 3-input NAND gate design in SkyBridge-CMOS fabric is shown to introduce gates consisting of multiple-nanowires. As we can see in the Figure 4.4, the 3-input NAND gate has a pull-up network with three parallel p-type transistors and a pull-down network with three serial n-type transistors. Three serial n-type transistors are implemented vertically on one nanowire and three parallel p-type transistors have to be built on three nanowires connected by SkyBridge-Interlayer-Connections and bridges.
Figure 4.4. 3-1 NAND Gate

4.2.3 AOI21 Compound Gate

As we have discussed in the circuit style section, SkyBridge-CMOS circuits are capable of using compound gates to perform complex logics in addition to NAND and NOR gates. An AOI21 gate is shown as an example because the AOI and OAI logic styles are efficient to be implemented with compound logic. As is shown in the Figure 4.5, with the same transistor-level design in CMOS technology, a 3-input AOI21 logic is performed with only two nanowires.
4.3 Full Adder

The SkyBridge-CMOS one-bit full adder design in the Figure 4.6 acts as an example of a simple functional circuit consisting of several gates. The transistor-level design shown in the schematic follows a conventional full adder design in planar CMOS technologies. Physical-level layout is designed in full-custom way to optimize the performance and density in both 2-D and 3-D technologies. The layout shows great benefit in density over conventional CMOS implementation: SkyBridge-CMOS full adder occupies eleven nanowires, leading to the area footprint of only 0.06 um$^2$, which is 28X denser than 16nm 2-D CMOS implementation. This small benchmark gives us an initial idea of the huge density benefit we achieve in the SkyBridge-CMOS fabric.
Figure 4.6. 1-bit Full Adder

4.4 Flip-flop

Flip-flop is a basic element for storing state information and thus essential for sequential circuits. Most of the conventional flip-flop designs in 2-D CMOS technology are applied in pass transistor logic style. However, pass transistor logic style is not desired in SkyBridge-CMOS fabric because of the larger voltage drop across drain to source of the junctionless transistors. Consequently we employ the design as shown in the Figure 4.6, which is realized by two cascaded 2-to-1-multiplexer-style latches with
complementary clock signals. The physical layout as shown in the Figure 4.7, is customized so that only an area footprint of 0.04 \( \text{um}^2 \) is necessary.

![1-bit Negative Edge Flip-flop](image)

**Figure 4.7.** 1-bit Negative Edge Flip-flop

### 4.5 6T-SRAM

SRAM is an important circuit application since it is widely used in fast on-chip applications such as caches and register files. It is thus necessary for a new technology to have an efficient implementation for SRAM design. However, it is challenging to realize the conventional 2-D CMOS SRAM design in SkyBridge-CMOS technology due to the inefficiency of transistor sizing. Consequently a new design suitable for SkyBridge-CMOS fabric is desired.

With the effort of ensure the SRAM cell stability and writability without transistor sizing, a SkyBridge-CMOS SRAM cell is designed and shown in the Figure 4.8. Similarly with traditional 2-D SRAM in CMOS technology, the SkyBridge-CMOS SRAM cell stores value with cross-coupled inverters and controls read and write accessibility with pass transistors. However, the customization of transistor strength is no
longer the same: to ensure writability, write-access transistor needs to be stronger than any of the transistors in cross-coupled inverters; to ensure read stability, read-access transistor has to be weaker than any of the transistors in the cross-coupled inverters. The cause of the difference is that the conventional customization for transistor strength is feasible only by customizing the geometry parameters and thus not possible in SkyBridge-CMOS fabric. In SkyBridge-CMOS, the way of customizing the transistor strength is applying various gate voltage levels, which is going to be described in details in later sections.

![Figure 4.8. SRAM Cell Schematic and Layout](image)

4.5.1 Read Operation

The read for the 6T SkyBridge-CMOS SRAM cell operates in two steps. First, with the read-access transistor in off state, Read-Bit-Line is initialized to “0” by bit line conditioning circuits. Then the p-type read-access transistor is turned-on by pulling down
Read-Word-Line. Only when the value stored inside the SRAM cell is 1, the floating zero Read-Bit-Line will be pull-up. Otherwise it remains to be 0. In this way, a read operation is finished.

In order to ensure the read stability, the read-access transistor should be weaker than any of the transistors in the cross-coupled inverters. The way how conventional CMOS 6T-SRAM satisfies the requirement is with transistor sizing, which is not feasible in SkyBridge-CMOS fabric. As is known, gate voltage level can influence the driving ability of transistors. Therefore, we customize the Read-Word-Line signal, the gate voltage of read-access transistors, to have weaker “0” of 0.1V so that the read-access transistor is weakly ON and thus read stability is achieved.

![Figure 4.9. SB-CMOS SRAM read operation](image)

**Figure 4.9.** SB-CMOS SRAM read operation

### 4.5.2 Write Operation

The write for the 6T SkyBridge-CMOS SRAM cell operates in two steps. First, with the write-access transistor in off state, Write-Bit-Line is driven to strong “0” or “1” by
write driver. Then the n-type write-access transistor is turned-on by pulling up Write-Word-Line. In this way, the node inside the SRAM cell is connected with Write-Bit-Line through the ON write-access transistor and Write-Bit-Line signal is written into the cell.

In order to ensure the writability, the write-access transistor should be stronger than any of the transistors in the cross-coupled inverters. Still the way in conventional CMOS 6T-SRAM design is by transistor sizing, while we use the alternative method of customize the Write-Word-Line signal, the gate voltage of write-access transistors, to have strong “1” of 1.2V. With the strongly ON write-access transistor driving, writability is ensured.

![Figure 4.10. SB-CMOS SRAM write operation](image)

4.5.3 Noise Margin and Writability

In order to verify the new SRAM design, the measurement of noise margin and writability is necessary. We follow the common way for measuring SRAM noise margin [14] with the methods and results illustrated in the following paragraphs.
For the hold margin measurement, the circuit shown in Figure 4.11 is built and we plot $V_2$ against $V_1$ and $V_1$ against $V_2$, which is known as the “Butterfly Curve”, based on the HSPICE [15] simulation result. From the plotting we see three stable states and hold noise margin is determined by the side length of the largest possible square that can fit between the curves. Similarly, the read margin is measured with circuit in Figure 4.12. With the read-access transistor trying to pull down the node “Q”, the butterfly curve shifts to the plotting shown in Figure 4.12. Based on the measurements, we see good hold noise margin of 0.3V and read noise margin of 0.15V. As for writability measurement, with the ON write-access transistor trying to write “1” or “0” into the cross-coupled inverters, we plot $V_2$ against $V_1$ and $V_1$ against $V_2$, fit the largest possible squares between the two curves when only one stable status is possible for both scenarios of writing “0” and “1” [16].

![Figure 4.11. 6T SB-CMOS SRAM Hold Margin Measurement Circuit and Results](image-url)
Figure 4.12. SB-CMOS SRAM Read Margin Measurement Circuit and Results

Figure 4.13. 6T SB-CMOS SRAM Writability Measurement Circuit and Results
CHAPTER 5
EVALUATION OF SKYBRIDGE-CMOS FABRIC

Following all the circuit design knowledge presented in the last chapter, now we are capable of doing some evaluation for SkyBridge-CMOS fabric. In this chapter, evaluation methodology will be firstly described. Then the evaluation results following the presented methods are going to be shown and analyzed.

5.1 Fabric Evaluation Methodology

In order to achieve credible results in terms of area footprint, power consumption, performance and noise resilience, a comprehensive evaluation methodology has been established. This evaluation includes information regarding material / device, schematic and physical level layout as shown in the flowchart in the Figure 5.1. More detailed methods in these steps will be introduced in the following paragraphs.

Figure 5.1. SkyBridge-CMOS Fabric Evaluation Methodology
5.1.1 Device and Material Level Methodology

The designs for basic fabric elements have been shown in Chapter 3. In order to see the effects of these component designs in the circuit, they have to be simulated and modeled so as to be considered during the circuit simulation. Mainly two kinds of core components including p-type transistors and SkyBridge-Interlayer-Connection need to be evaluated.

First we will see the detailed evaluation methodology for p-type transistor modeling. The method is similar with the previous one for horizontal nanowire device modeling [17] and is presented in the flow chart as shown in Figure 5.2. First of all, we develop the process for building the p-type transistors based on the material-level information and geometry parameters we have in our component design. Second, we do the process simulation in Sentaurus Process to obtain the transistor structure, which is going to provide the necessary information in the following device simulation. Third, Sentaurus Device takes process simulation results and does the physical-level simulation to generate the device I-V and C-V characteristics. After that, the mathematic tool named as DataFit [18] performs regression analysis and polynomial fits are applied on device characteristics to get the mathematic expression. At last, we build the behavioral HSPICE modeling based on expressions describing device characteristics. In this way, from our physical level design we obtain a device model that is going to be used in the HSPICE circuit simulations. This device model has been verified with HSPICE simulation and the result of DC analysis is shown in the Figure 5.3.
Figure 5.2. P-type Transistor Evaluation Method

Figure 5.3. Transistor IDS-VDS Characteristics from TCAD Simulation
After introducing the transistor modeling, the method of SkyBridge-Interlayer-Connection evaluation will be described. Similar method of acquiring device characteristics with Sentaurus Process and Device is followed. From the plotting of the characteristics as shown in Figure 5.4, we see a nearly perfect Ohmic I-V characteristic, which is desired for the connection between p- and n-doped regions. What is more, the coupling capacitance between two terminals is also negligible. The detailed modeling with resistors and capacitances for SkyBridge-Interlayer-Connection is shown in the Figure 5.5 and will be used in the HSPICE circuit simulation.

Figure 5.4. SkyBridge-Interlayer-Connection I-V Characteristics
5.1.2 Circuit and Layout Design

With evaluation results for all the SkyBridge-CMOS components ready, we are able to do HSPICE simulation in circuit-level by using the models of these elements. Benchmark circuits are firstly designed in schematic-level following the circuit style introduced in Chapter 3. Then these schematics are designed in physical-level layout, with which we can estimate the area footprint. After that, we build HSPICE netlist to describe the layout with all the transistor and interconnection models. At last, test vectors are applied to the netlist for functional verification.
5.1.3 RC Extraction

The previous HSPICE simulation results are only good enough for combinational function validation. For better results in terms of signal integrity, performance, power consumption and noise robustness, the parasitic resistances and capacitances need to be considered. Due to the absence of CAD tools for SkyBridge-CMOS, RC extraction has to be done manually by looking into the layout to measure the parasitic resistances and capacitances. These parasitic elements are modeled following the Predictive Technology Model (PTM) [19]. Then we attach extraction results to the original schematic-level HSPICE netlist.

5.1.4 HSPICE Simulation

With the physical-level HSPICE netlists, various simulations can be applied for evaluations in noise resilience, performance and power consumption. The detailed methods and assumptions are introduced in the following paragraphs.

In order to compare the noise resilience for circuits built in SkyBridge and SkyBridge-CMOS, we need to build scenarios with noise attacking signals in these three fabrics, do HSPICE simulations and see how signals are influenced. As is shown in Figure 5.6, two kinds of coupling noises exist in circuits built with vertical nanowires: coupling noise between different layers of one nanowire and noise between adjacent nanowires. We assume that for one victim of coupling noises, there are at most one aggressor from the same nanowire and two aggressors from the adjacent nanowires due to the common way of routing in real circuits. Consequently we build physical-level HSPICE netlists for three scenarios: one aggressor from the same nanowire, one aggressor from the same nanowire
and the other from adjacent nanowire, one aggressor from the same nanowire and two from adjacent nanowires. In order to make the scenario authentic, victim and all the aggressors are generated by real gates and all these signals are driving average loads, which are fan-out of four minimum-sized inverters. At last noise resilience can be evaluated by checking the noise margin of victims in different fabrics.

![Image](image.png)

**Figure 5.6.** Coupling noise scenario (with GND shielding for SkyBridge)

As for the performance evaluation, two kinds of metrics need to be considered including throughput (in operations / second) and delay (in nanoseconds). Throughput shows how many instructions can be operated in unit time at most; delay shows how soon an operation can be finished. Both of them are important metrics. For the evaluation of delay, we do analysis for the circuits-under-test to find the critical paths and accordingly setup input test vectors. By applying all these combinations leading to switches flowing through critical paths, we find the maximum propagation delay from input crossing 50% to output crossing 50%. Again, all the inputs to the circuits-under-test are generated by gates and outputs are loaded with four inverters. After the critical delay is defined,
throughput is automatically known for static circuits without pipelining from the multiplicative inverse of delay. For static circuit with pipelining, throughput is instead defined by the maximum delay of critical stages. This is also true for dynamic SkyBridge circuits since they are pipelined by the implicit latching between stages.

For power evaluation, still two kinds of metrics are necessary: power consumption (in Watts) and power efficiency (in operations / J). In order to measure the largest possible power consumption, each circuit-under-test are operated in its largest frequency. We ensure the input test vectors are random generated and large enough to make the result credible. After power consumption is known, power efficiency can be obtained by computing the performance per watt. Similarly, all the circuits are simulated with fan-out of four inverters.

5.1.5 CMOS Baseline Evaluation

In order to serve as the baseline for the SkyBridge-CMOS fabric evaluation results, identical benchmarking needs to be done for CMOS technology. First of all, state-of-art CAD tools are used to build benchmark circuits in 45nm CMOS technology: benchmark circuits are expressed in Verilog HDL language, which is later taken by Synopsys Design Compiler for the synthesize to generate the gate-level netlist; Cadence Encounter does the automatic placement & routing for the gate-level design; Cadence Virtuoso translates gate-level into transistor-level netlist, verifies the level versus schematic layout and generates the physical level netlist. Afterwards, the scaling factors are used to achieve the results in 16nm CMOS technology. [20] [21]
5.2 Evaluation Results

In this section, following the methodology and assumptions introduced before, a comprehensive evaluation for SkyBridge-CMOS fabric is done. All the results are going to be shown and analyzed to make us understand the advantages and disadvantages of enabling static circuits in the 3-D integration concept similar with SkyBridge.

5.2.1 Noise Resilience Evaluation

In the original SkyBridge fabric, the inner metal layers in coaxial routing structures are always connected to ground instead of carrying signals, which is customized for providing ground shielding to remove coupling noise between outer metal and inner silicon layers. The reason why ground shielding is essential can be seen from the noise evaluations for SkyBridge circuits with or without inner metal layer connected to ground. The evaluation is done for the condition when the floating victim signals “1” is pulled down by the falling aggressors during “HOLD” phases of the victim signals. From noise resilience evaluation results shown in Figure 5.7, it is obvious that ground shielding for inner metal layer is essential to keep the circuits function correctly [6].

![Figure 5.7. Victim Signals for SkyBridge Noise Evaluations for Scenarios in Section](image)

However, the interconnection engineering method in SkyBridge fabric attaches large ground capacitances to signals and thus slows the performance and increases power
consumption. It is thus beneficial trying to avoid the ground shielding mechanism and at the same time keep the circuits function well in SkyBridge-CMOS. Due to the fact that static circuits are more robust against noise, it is possible that the SkyBridge-CMOS circuits are able to function correctly without ground shielding. Consequently we follow the noise resilience evaluation methods for the experimental scenario with no ground shielding for SkyBridge-CMOS and have the results as shown in the Figure 5.8.

![Figure 5.8. Noise Resilience Evaluation for SkyBridge with GND Shielding and SkyBridge-CMOS](image)

From the evaluation results for both SkyBridge and SkyBridge-CMOS fabrics, it is obvious that SkyBridge-CMOS circuits are far better at noise resilience. First of all, output signals of SkyBridge-CMOS circuits have better noise margin than those of SkyBridge circuits. Second, a SkyBridge-CMOS gate can automatically reset its noise in output voltage because of the static circuit style, while noises in SkyBridge gates always remain. At last, no performance and power overhead from additional noise mitigation mechanism exist in SkyBridge-CMOS circuits.
5.2.2 Initial Benchmarking

For the evaluation in terms of performance and power consumption, an initial benchmarking with 4-bit array-based multiplier is implemented. The design of 4-bit multiplier, as is shown in the Figure 5.9, performs the multiple partial product additions with 4-bit carry-save adders and at last one 4-bit carry-propagate adder. The multiplier is designed and built in physical level in SkyBridge-CMOS, SkyBridge as well as conventional CMOS to allow us to compare between different fabrics. The physical design of one carry-save adder cell in SkyBridge-CMOS is shown in Figure 5.10.

Figure 5.9. 4-bit Array-based Multiplier
Following the methodology introduced before, the following initial benchmarking results with 4-bit array multiplier are acquired and shown in the Table 5.1. When compared with SkyBridge results, for the performance metrics we see better latency but lower throughput in SkyBridge-CMOS. The reason for the lower throughput is the less pipelined static circuit implementation in SkyBridge-CMOS. In terms of power efficiency, SkyBridge-CMOS is much better than SkyBridge for the following reasons: the less complex clocking due to the static SkyBridge-CMOS circuit style; no redundant switches between consecutive zeros; no noise mitigation overhead from ground shielding. The better power efficiency and lower operation frequency in SkyBridge-CMOS also
automatically lead to a large reduction in power consumption. The density of SkyBridge-CMOS is also good that it is much better than the dual-rail SkyBridge 4-bit multiplier and only slightly worse than the single-rail SkyBridge result.

Comparing with conventional CMOS, we see significant improvement in density for the 3-D stacked transistors and routing structures. SkyBridge-CMOS also dominates in power efficiency and power consumption because of the lower power junctionless devices and the smaller interconnection overhead in the denser designs. However, SkyBridge-CMOS loses a lot in both performance metrics. The main reason for the performance loss is the low performance device in SkyBridge-CMOS. As is known, the intrinsic delay $CV/I$ is important for the performance of a technology [22]. In SkyBridge-CMOS, due to the structure and junctionless operation, transistors have larger intrinsic delays. Moreover, the device driving ability is also weaker, making it slower when driving interconnections.

<table>
<thead>
<tr>
<th></th>
<th>Latency (ps)</th>
<th>Throughput (ops. / sec.)</th>
<th>Power (μW)</th>
<th>Performance / Watt (Ops. / J)</th>
<th>Area (μm²)</th>
</tr>
</thead>
<tbody>
<tr>
<td>SkyBridge (dual-rail)</td>
<td>524</td>
<td>5.09E+9</td>
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<td>1.23E+14</td>
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<tr>
<td>SkyBridge (single-rail)</td>
<td>923</td>
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<td>27.9</td>
<td>1.46E+14</td>
<td>1.06</td>
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<tr>
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<td>1.98E+14</td>
<td>1.09</td>
</tr>
<tr>
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<td>4.97E+9</td>
<td>172</td>
<td>2.89E+13</td>
<td>50.1</td>
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</tbody>
</table>

Table 5.1. Initial Benchmarking Results
5.2.3 Performance Optimization

As is shown in the last section, SkyBridge-CMOS circuits are not advantageous in throughput due to the lower performance of device and the static circuit style. One solution for the challenge is having a new device design for high performance applications at the cost of higher power consumption. However, circuit-level optimizations by pipelining for benchmarking results are also feasible to solve the throughput problem even without device engineering.

Using the afore-introduced flip-flop design, we can achieve pipelined design by inserting flip-flops between stages. For the 4-bit array multiplier, experiments with at most three stages are implemented with the results shown in the Figure 5.11. After pipelining, the throughput in SkyBridge-CMOS benchmark has been similar with the other results. At the same, power and density of SkyBridge-CMOS is still far better than CMOS. Compared with SkyBridge, power efficiency is in between two implementations of SkyBridge and density is similar with the dual-rail implementation. Consequently we conclude that by doing circuit-level performance optimization, we can get comparable throughput with other technologies and still win over the opponents in power, area or noise resilience.
5.2.4 Large Benchmarking: WISP-4 and 16-bit Multiplier

With the experience in circuit design and optimization we obtain from 4-bit multiplier, further evaluations in performance, power and area can be implemented with larger scale benchmarking. First, a 4-bit WIre Streaming Processor (WISP-4) benchmarking for comprehensive practice in logic and arithmetic circuit, memories as well as inter-circuit connections will be included. Second, a 16-bit array-based multiplier benchmarking will be presented to provide evaluation for larger scale circuits.
a) WISP-4 Benchmarking

During the WISP-4 Benchmarking, the simple 4-bit Wlre Streaming Processor is built at transistor level in SkyBridge-CMOS fabric, functionally verified and evaluated against the baselines in SkyBridge and conventional CMOS technologies. As shown in the Figure 5.12, the WISP-4 microprocessor uses load-store architecture and consists of five function stages including Instruction Fetch, Instruction Decode, Register File, Arithmetic Logic Unit and Write Back. We build the entire processor following the circuit design guidelines presented in Chapter 3.

![WISP-4 Architecture and Instruction Set](image)

**Figure 5.12.** WISP-4 Architecture and Instruction Set

During the first stage, program counter generates the instruction address, which is then decoded as the instruction ROM word line. In WISP-4, one instruction consists of nine bits as shown in the Figure 5.13 and five kinds of operations are supported including move, move immediate, addition, multiplication and stall. Then in the second stage,
instruction is decoded into word lines of register files and control signals. After that, the Register File stage loads the correct operands, which are fed into the ALU stage for the calculations including addition and multiplication. At last, the results are written back into the register files. The block diagrams are shown in the Figure 5.13 for each stage.

**Figure 5.13.** Block Diagram of WISP-4 Stages

From the previous section we have seen that SkyBridge-CMOS circuits will lose in throughput against the baselines in conventional CMOS and SkyBridge when no deeper pipelining is applied. We thus apply further circuit level optimizations for the microprocessor, break the five functional blocks into more pipeline stages and improve the throughput. In order to achieve comparable throughput with CMOS and SkyBridge baselines, a thirteen-stage design is necessary for SkyBridge-CMOS WISP-4. By following the afore-mentioned methodology, evaluations in terms of performance, power and area footprint are made and shown in the Table 5.2.
Table 5.2. WISP-4 Benchmarking Results

<table>
<thead>
<tr>
<th></th>
<th>Throughput (ops. / sec.)</th>
<th>Power (μW)</th>
<th>Performance / Watt (Ops. / J)</th>
<th>Area (μm²)</th>
</tr>
</thead>
<tbody>
<tr>
<td>SkyBridge-CMOS</td>
<td>4.55E+9</td>
<td>186</td>
<td>2.45E+13</td>
<td>10.6</td>
</tr>
<tr>
<td>SkyBridge</td>
<td>5.09E+9</td>
<td>301</td>
<td>1.69E+13</td>
<td>9.52</td>
</tr>
<tr>
<td>16nm CMOS</td>
<td>4.31E+9</td>
<td>886</td>
<td>4.86E+12</td>
<td>289</td>
</tr>
</tbody>
</table>

From the results, first of all we should notice that SkyBridge-CMOS is doing better in all the metrics when compared with conventional CMOS technology. These benefits prove that as the circuit scale goes up and more interconnections and memories are taken into consideration, SkyBridge-CMOS technology keeps the benefit over the CMOS technology. When compared with SkyBridge fabric, the power efficiency is much better while the throughput and area footprint are slightly worse.

b) 16-bit Array Multiplier

16-bit array-based multiplier is a larger circuit for a decent benchmarking. The size is larger so that we can see more influences from interconnections. The design of 16-bit array-based multiplier, as shown in the Figure 5.14, consists of sixteen 16-bit carry-save adders to sum up all the partial products generated by the AND gates in each carry-save adder cell. The sum and carry bits from the last iteration of addition are added by a 16-bit 2-level Carry-Lookahead-Adder at the last of multiplication. As for the physical-level designs, we can simply continue using the original CSA cell design presented during the 4-bit multiplier benchmarking. In SkyBridge-CMOS, two versions of 16-bit multipliers are implemented: one is not pipelined; the other is 10-stage pipelined.
By building the entire designs in different technologies and doing HSPICE simulation, the results are shown in the Table 5.3. For the unpipeliend version, we have observed significant advantages in power and area metrics, which again implies that there are intrinsic benefits lying in SkyBridge-CMOS fabric in terms of power consumption and area. As for the pipelined version, SkyBridge-CMOS loses some of the area benefit when compared with other technologies. The reason for the narrower area gap is that the flip-flop count for pipelining increases severely as the bit number of operands goes up. On the other hand, as fast as 3X faster throughput has been achieved when compared with conventional CMOS technology. With the baseline of SkyBridge fabric, advantages in throughput and power efficiency are witnessed while the density is worse in SkyBridge-CMOS fabric.

Figure 5.14. 16-bit Multiplier Design
<table>
<thead>
<tr>
<th></th>
<th>Delay (ns)</th>
<th>Throughput (ops. / sec.)</th>
<th>Power (μW)</th>
<th>Performance / Watt (Ops. / J)</th>
<th>Area (μm²)</th>
</tr>
</thead>
<tbody>
<tr>
<td>SkyBridge-CMOS</td>
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<td>5.81E+8</td>
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<td>5.05E+12</td>
<td>14.5</td>
</tr>
<tr>
<td>(Unpipelined)</td>
<td></td>
<td></td>
<td></td>
<td></td>
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</tr>
<tr>
<td>SkyBridge-CMOS</td>
<td>2.19</td>
<td>4.57E+9</td>
<td>1290</td>
<td>3.55E+12</td>
<td>36.3</td>
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<tr>
<td>(10-stage Pipelined)</td>
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<td></td>
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<td></td>
<td></td>
</tr>
<tr>
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<td>2580</td>
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<td>721</td>
</tr>
<tr>
<td>SkyBridge (Dual-rail)</td>
<td>1.79</td>
<td>3.73E+9</td>
<td>1020</td>
<td>3.13E+12</td>
<td>22.3</td>
</tr>
</tbody>
</table>
CHAPTER 6

CONCLUSION

In this dissertation, a new fabric, named as SkyBridge-CMOS, has been proposed and evaluated. Confronted with all the challenges from dynamic circuit implementations in SkyBridge fabric, this new fabric enables the extension of static circuit implementation in the 3-D integration similar with the original SkyBridge fabric.

During this research, innovations in the device / material level have been proposed: Molecular technology helps to achieve nanowires with well-controlled different doping regions; Corresponding p-type core components including p-type transistors and contacts are designed and engineered; SkyBridge-Interlayer-Connection solves the connection problem between different doping regions; All these new designs contributes the realization of various kinds of static circuits including logic gates, arithmetic circuits, flip-flops, memories as well as microprocessors. At last, a comprehensive evaluation methodology taking information in all levels into consideration is developed, which is followed to achieve evaluation results in noise resilience, power, area and performance. Several benchmarking has been built for the evaluation including 4-bit and 16-bit array-based multiplier and WISP-4 microprocessor.

We have applied comprehensive analysis on all the evaluation results to understand the benefit and shortcomings of SkyBridge-CMOS fabric. When compared with CMOS technology, we see benefits in all aspects including performance, power and area for large-scale circuits. As for the comparison with original SkyBridge fabric, on one hand better noise resilience is observed in SkyBridge-CMOS fabric due to its static circuit
implementation, on the other hand we see intrinsic benefits in terms of power consumption and area, which allows us to perform more performance optimization at the cost of sacrificing some of the benefits in resource consumptions.
BIBLIOGRAPHY


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